

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional) <b>FIS920030173</b>	Application Number <b>10/751,208</b> Not Yet Assigned
Applicant(s) <b>Chen et al.</b>	
Filing Date <b>01/02/04</b> Concurrently Herewith	Group Art Unit <b>2222</b> Unknown

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TYT		6,251,751	06/26/2001	Chu et al.	—	—	—
TYT		6,375,749	04/23/2002	Boydston et al.	—	—	—
TYT		6,348,420	02/19/2002	Raaijmakers et al.	—	—	—
TYT		6,444,591	09/03/2002	Schuegraf et al.	—	—	—
TYT		5,397,738	03/14/95	Takagi	—	—	—
TYT		6,106,613	08/22/00	Sato et al.	—	—	—
TYT		2002/00986627	07/25/02	Pomarede et al.	—	—	—
TYT		2003/0036268	02/20/03	Brabant et al.	—	—	—

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

TYT		"Dedicated Pre-Clean Reduces Epi's Thermal Budget", Arkadii V. Samoilov, Dale Du Bois, Paul B. Comita & David Carlson, Applied Materials Inc., Santa Clara, CA, November 1, 2000, 6 pages <a href="http://www.e-insite.net/semiconductor/index.asp?layout=articlePri...">http://www.e-insite.net/semiconductor/index.asp?layout=articlePri...</a>

EXAMINER <b>THANH TRAN</b>	DATE CONSIDERED <b>5/4/05</b>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.